PATENT

Docket No: NAUP0470USA

## ASSIGNMENT OF INVENTION

In consideration of the payment by ASSIGNEE to ASSIGNOR of the sum of One Dollar (\$1.00), the receipt of which is hereby acknowledged, and for other good and valuable consideration.

Name:	Jeng-Wei Yang	Nationality: R.O.C	
Address:	Address: No. 2-4, Yang-Ming St., Chang-Hua City, Taiwan, R.O.C.		
Name:	Tse-Yuan Lo	Nationality: R.O.C	
Address:	6A, No. 76, Sec. 1, Chin-Shan S.	Rd., Taipei City, Taiwan, R.O.C.	
No.3, Li-Hsin I and the success the number of the success the success the success the success that the success the success the success the success that the success the success that the success	sors assigns and legal representate any and all improvements which ING COMPOSITION AND METHOD	I Park, Hsin-Chu, Taiwan, R.O.C. ives of the ASSIGNEE the entire right, title, and a are disclosed in the invention entitled:  OF WASHING A SILICON WAFER	
(a)	U.S. patent application executed o	n even date	
(b)	U.S. patent application executed o	n	
(c)	U.S. application serial no.		
(d) p	atent no. issu	ed	
and, in and to,	all Letters Patent to be obtained division, renewal, or substitute t	for said invention by the above application or ant hereof, and as to letters patent any reissue or re-	

Assignment, Page 1 of 2

has been or will be made or entered into which would conflict with this assignment;

ASSIGNOR further covenants that ASSIGNEE will, upon its request, be provided promptly with all pertinent facts and documents relating to said invention and said Letters Patent and legal equivalents as may be known and accessible to ASSIGNOR and will testify as to the same in any interference, litigation or proceeding related thereto and will promptly execute and deliver to ASSIGNEE or its legal representatives any and all papers, instruments or affidavits required to apply for, obtain, maintain, issue and enforce said application, said invention and said Letters Patent and said equivalents thereof which may be necessary or desirable to carry out the proposes thereof.

IN WITNESS WHEREOF, We have hereunto set hand and seal this 11/5 > (Date of signing).

(Type name of inventor)

Signature of INVENTOR

Jeng-Wei Yang

Tse-Yuan Lo

Jse- Yuan Lo

PATENT Docket No: NAUP0470USA

## COMBINED DECLARATION AND POWER OF ATTORNEY

As a below named inventor, I hereby declare that:

I believe I am the sole (if only one name appears below), or joint (if more than one name appears), original and first inventor of the subject matter which is claimed and for which a patent is sought on the invention entitled:

"CLEANING COMPOSITION AND METHOD OF WASHING A SILICON WAFER"

+ The specification for the above entitled invention is filed herewith.
The specification for the above entitled invention was filed previously
ith application serial number:Filing Date:
I hereby state that I have reviewed and understand the contents of the above identified ecification, including the claims, as amended by any amendment referred to above.
I acknowledge the duty to disclose information which is material to the patentability of a invention disclosed in this application in accordance with Title 37, Code of Federal gulations, Section 1.56 (a). I further acknowledge the duty in any continuation-in-part polication to disclose to the Patent and Trademark Office all information known to be material the patentability of the invention disclosed in this application, as defined in 1.56, which came available to me between the filing date of the prior application and the filing date of this polication.
PRIORITY CLAIM
There is no claim of priority  Claim of priority is based on the following:  Division Application of No. = 09/683, >47  Filing date = >00(/12/5)
POWER OF ATTORNEY

As a named inventor, I hereby appoint the following attorney to prosecute this application and to transact all related business in the Patent and Trademark Office:

Winston Hsu, Registration Number 41,526 5F, No.389, Fu-Ho Rd., YUNGHO City, Taipei Hsien, Taiwan, R.O.C. TEL: +886-2-8923-7350

## DECLARATION

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment or both under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued hereon.

Date:	11/5. 2001	Jeng-Wei Yang
	Printed Name:	Jeng-Wei Yang
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	and Residence	R.O.C.
	Citizen of:	R.O.C
Date:	11/5, 2001	Je- Yuan Lo
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	Citizen of:	R.O.C